Scattering Matrix Tomography

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Abstract

Some more text. Our SMPR-3D algorithm retrieves an adaptive approximation to the scattering matrix and refines probe positions and non-parametric probe aberrations. In a second step, we retrieve the three-dimensional scattering potential from the scattering matrix by solving an inverse multislice problem. Compared to direct multi-slice inversion from scanning diffraction measurements, our algorithm enjoys favorable computational complexity, accelerating large field-of-view reconstructions. We demonstrate the algorithm experimentally

Introduction

Spurred by the development and widespread availability of fast pixelated direct electron detectors (DEDs), scanning transmission electron microscopy (STEM) is undergoing a computational imaging renaissance. Single-electron-sensitive, high-speed, and high-dynamic-range DEDs combined with advanced reconstruction algorithms enable computational imaging methods that surpass conventional methods in resolution and sensitivity. Electron ptychography, a coherent diffractive imaging method that retrieves phase-information from 4D-STEM datasets, is finally reaching the full potential its inventors envisioned decades ago. Diffraction-limited resolution far bevond the numerical aperture of the microscope and, in the case of multiple-scattering samples, lattice vibration-limited resolution are now possible with suitable materials. We can visualize beam-sensitive specimens with higher contrast and resolution than conventional methods, as researchers have demonstrated with X, Y, and Z. For thicker samples, we can extract three-dimensional information by undoing beam propagation and multiple scattering effects. Many proposed and demonstrated algorithms for undoing multiple scattering effects in the STEM for general samples treat the propagation of every single probe position separately. Although this strategy

is highly parallelizable, it has a high computational complexity for thick samples and large fields of view. Here, we introduce a three-dimensional inversion algorithm based on the scattering matrix formalism that scales favorably to large 4D-STEM datasets. It is inspired by a fast, memory-efficient forward model for simulating 4D-STEM experiments called the partitioned Plane-wave Reciprocal-space Interpolated S-matrix (partitioned PRISM) algorithm. We first introduce this forward model with the necessary nomenclature, then formulate the corresponding inverse problem given 4D-STEM measurements, and finally demonstrate it experimentally with two applications in materials and life sciences.

Approximate solutions to the Schroedinger equation for fast electrons

The evolution of the slow-moving portion of the wavefunction along the optical axis z can be described by the Schr"{0}dinger equation for fast electrons Kirkland (2020)

$$\frac{\partial}{\partial z}\psi(\mathbf{r}) = \frac{i\lambda}{4\pi} \nabla_{xy}^{2} \psi(\mathbf{r}) + i\sigma V(\mathbf{r})\psi(\mathbf{r}), \qquad (1$$

where λ is the relativistic electron wavelength, ∇_{xy}^2 is the 2D Laplacian operator, σ is the relativistic beam-sample interaction constant and $V(\mathbf{r})$ is the electrostatic potential of the sample. The formal operator solution to Eq.@eq-paraxial_schroedinger is given by Kirkland (2020),

$$\psi_f(\mathbf{r}) = \exp\left\{ \int_0^z \left[\frac{i\lambda}{4\pi} \nabla_{xy}^2 + i\sigma V(x, y, z') \right] dz' \right\} \psi_0(\mathbf{r}),$$
(2)

where $\psi_f(\mathbf{r})$ is the exit wavefunction after traveling a distance z from the initial wave $\psi_0(\mathbf{r})$. This expression is commonly approximately solved with the multislice algorithm first given by ?, which alternates solving the two operators using only the linear term in the series expansion of the exponential operator. In the multislice algorithm, we first divide up the

sample of total thickness t into a series of thin slices with thickness Δz . Solving for the first operator on Eq.~?? yields an expression for free space propagation between slices separated by Δz , with the solution given by

$$\psi_f(\mathbf{r}) = \mathcal{P}^{\Delta z} \psi_0(\mathbf{r}),$$

where $\mathcal{P}^{\Delta z}$ is the Fresnel propagator defined by

$$\mathcal{P}^{\Delta z}\psi:=\mathcal{F}_{\mathbf{q}}^{\dagger}\left[\mathcal{F}_{\mathbf{r}}\left[\psi\right]e^{-i\pi\lambda\mathbf{q}^{2}\Delta z}\right],$$

where $\mathbf{q} = (q_x, q_y)$ are the 2D Fourier coordinates and $\mathbf{r} = (x, y)$ are the 2D real space coordinates. $\mathcal{F}_{\mathbf{x}}[\cdot]$ denotes the two-dimensional Fourier transform with respect to \mathbf{x} and $\mathcal{F}_{\mathbf{x}}^{\dagger}[\cdot]$ the 2D inverse Fourier transform with respect to \mathbf{x} . We can then write one iteration of the multislice algorithm as

$$\mathcal{T}_k^V \psi = \psi \cdot e^{i\sigma V_k} \tag{3}$$

where V_k is the projected potential at slice k.

$$\mathcal{M}_{\mathsf{T}}^{V}\psi = \prod_{\mathsf{k}=0}^{\mathsf{T}} \left(\mathcal{P}^{\Delta z}\mathcal{T}_{\mathsf{k}}^{V}\right)\psi$$

The 4D-STEM intensity is then

$$I(\mathbf{q}, \boldsymbol{\rho}) = \left| \mathcal{F}_{\mathbf{r}} \left[\sum_{\mathbf{h} < h_{max}} \Psi(\mathbf{h}) e^{-2\pi i \mathbf{h} \cdot \boldsymbol{\rho}} \mathcal{M}_{\mathsf{T}}^{V} e^{2\pi i \mathbf{h} \cdot \mathbf{r}} \right] \right|^{2}.$$

Defining the interpolation weights as a matrix $w \in \mathbb{R}^{|\mathcal{P}| \times B}$ that stores the interpolation weights for each beam, we can then compute the 4D-STEM intensities as

$$I(\mathbf{q}, \boldsymbol{\rho}) = \left| \mathcal{F}_{\mathbf{r}} \left[\sum_{\mathsf{b}=1}^{\mathsf{B}} \Psi(\mathbf{h}_{\mathsf{b}}) \, e^{-2\pi i \mathbf{h}_{\mathsf{b}} \cdot \boldsymbol{\rho}} \cdot \mathbf{C}_{\boldsymbol{\rho}, \mathbf{r}} \left[e^{2\pi i \mathbf{h}_{\mathsf{b}} \cdot \boldsymbol{r}} \sum_{\mathsf{p} \in \mathcal{P}} w_{\mathsf{p}, \mathsf{b}} e^{-2\pi i \mathbf{h}_{\mathsf{p}} \cdot \boldsymbol{r}} \mathcal{S}_{\mathsf{r}, \mathsf{p}} \right] \right] \right|^{2}.$$

References

Kirkland, E. J. 2020. Advanced Computing in Electron Microscopy, 3rd Edition. Springer.